



# Electronic Filing System (EFS) Data

## Electronic Patent Application Submission

### USPTO Use Only

EFS ID: 55539  
Application ID: 10679844 

Title of Invention: METHODS AND SYSTEMS FOR  
INSPECTING RETICLES USING  
AERIAL IMAGING AT OFF-  
STEPPER WAVELENGTHS

First Named Inventor: Stan Stokowski

Domestic/Foreign Application: Domestic Application

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Filing Type:

Confirmation number: 3733

Attorney Docket Number: 5589-04201

Total Fees Authorized:

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## TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	METHODS AND SYSTEMS FOR INSPECTING RETICLES USING AERIAL IMAGING AT OFF-STEPPER WAVELENGTHS	
Application Number:	10/679844 	
Date:	2003-10-06	
First Named Applicant:	Stan Stokowski	
Confirmation Number:	3733	
Attorney Docket Number:	5589-04201	
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Submitted by:	Elec. Sign.	Sign. Capacity
Kevin L. Daffer Registered Number: 34146	Kevin L. Daffer	Attorney
Documents being submitted us-ids	Files 5589-04001IDS2-usidst.xml us-ids.dtd us-ids.xsl	
Comments		

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0



## Title of Invention

### METHODS AND SYSTEMS FOR INSPECTING RETICLES USING AERIAL IMAGING AT OFF-STEPPER WAVELENGTHS

Application Number: 10/679844



Confirmation Number: 3733

First Named Applicant: Stan Stokowski

Attorney Docket Number: 5589-04201

Search string: ( 6636301 or 6614520 or 6529621 ).pn.

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6636301	2003-10-21	Kvamme et al.			
	2	6614520	2003-09-02	Bareket et al.			
	3	6529621	2003-03-04	Glasser et al.			

## Signature

Examiner Name	Date